

East 8 USPB USPT, WPID, JPO

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L10	1641900	etch\$ or patern\$ or remov\$	JPO; DERWENT	OR	OFF	2004/12/22 12:08
L11	311968	resist or photoresist or mask or photomask	JPO; DERWENT	OR	OFF	2004/12/22 12:09
L12	21586	fluorinat\$	JPO; DERWENT	OR	OFF	2004/12/22 12:09
L13	10852	"organic dielectric" or "organic insulat\$" or "low k" or "low dielectric"	JPO; DERWENT	OR	OFF	2004/12/22 12:09
L14	9	10 and 11 and 12 and 13	JPO; DERWENT	OR	OFF	2004/12/22 10:48
L15	926	10 with 12	JPO; DERWENT	OR	OFF	2004/12/22 10:48
L16	88	11 and 15	JPO; DERWENT	OR	OFF	2004/12/22 10:48
L17	84	16 not 14	JPO; DERWENT	OR	OFF	2004/12/22 10:48
L18	434948	etch\$ or patern\$ or remov\$	US-PGPUB	OR	OFF	2004/12/22 11:09
L19	12453	fluorinat\$	US-PGPUB	OR	OFF	2004/12/22 11:08
L20	94143	resist or photoresist or mask or photomask	US-PGPUB	OR	OFF	2004/12/22 11:08
L21	7156	"organic dielectric" or "organic insulat\$" or "low k" or "low dielectric"	US-PGPUB	OR	OFF	2004/12/22 11:09
L22	715	18 with 19	US-PGPUB	OR	OFF	2004/12/22 11:09
L23	149	22 same 20	US-PGPUB	OR	OFF	2004/12/22 11:09
L24	26	21 same 23	US-PGPUB	OR	OFF	2004/12/22 11:10
L25	123	23 not 24	US-PGPUB	OR	OFF	2004/12/22 11:15
L26	1884156	etch\$ or patern\$ or remov\$	USPAT	OR	OFF	2004/12/22 12:08
L27	304738	resist or photoresist or mask or photomask	USPAT	OR	OFF	2004/12/22 12:09
L28	39006	fluorinat\$	USPAT	OR	OFF	2004/12/22 12:09
L29	14633	"organic dielectric" or "organic insulat\$" or "low k" or "low dielectric"	USPAT	OR	OFF	2004/12/22 12:09
L30	2296	26 with 28	USPAT	OR	OFF	2004/12/22 12:10
L31	364	30 same 27	USPAT	OR	OFF	2004/12/22 12:10
L32	28	29 same 31	USPAT	OR	OFF	2004/12/22 12:10
L33	336	31 not 32	USPAT	OR	OFF	2004/12/22 12:10